

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Takenori GOTO**

Serial No.: **Not Yet Assigned**

Filed: **June 26, 2001**

For: **NITRIDE BASED SEMICONDUCTOR LASER DEVICE AND METHOD OF
FABRICATING THE SAME**

JC997 U.S. PTO
09/888419
06/26/01

#3 / 1DS
11-21-01
R. Stokes

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

June 26, 2001

Sir:

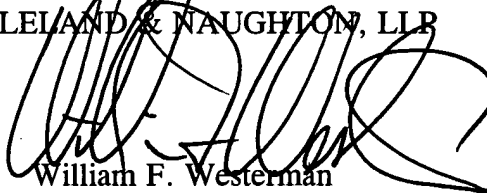
In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

Deposit Account No. 01-2340.

Respectfully submitted,
ARMSTRONG, WESTERMAN, HATTORI
MCLELAND & NAUGHTON, LLP



William F. Westerman
Reg. No. 29,988

Atty. Docket No.: 010802
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
Tel: (202) 659-2930
Fax: (202) 887-0357
WFW/ll
Enclosures: PTO-1449; References (1)